Electronic Pat	ent App	lication Fe	Transm	ittal			
Application Number:	109	10572353					
Filing Date:	05-	05-Jan-2007					
Title of Invention:	MI	MICROLITHOGRAPHY METHOD USING A MASK WITH CURVED SURFACE					
First Named Inventor/Applicant Name:	Jea	Jean-Charles Guibert					
Filer:	Ma	Marvin Jay Spivak/Slobodanka Alic					
Attorney Docket Number:	283	287990US2PCT					
Filed as Large Entity	•						
U.S. National Stage under 35 USC 371 F	iling Fee	5					
Description		Fee Code	Quantity	Amount	Sub-Total ir USD(\$)		
Basic Filing:					1		
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Utility Appl issue fee		1501	1	1510	1510		

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	2	3	6
	Tot	Total in USD (\$)		